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INFORMATION DISCLOSURE STATEMENT TRANSMITTAL To Commissioner For Patents Enclosed herewith is a Form PTO-1449, any required copies of documents listed thereon, and any concise explanation of their relevance is indicated below per 37 CFR 1.97.	Application Number	10/537028 10/537028
	Filing Date	
	First Named Inventor	PINEDA DE GYVEZ, Jose
	Group Art Unit	281.6
	Examiner Name	Dinh Le
Atty. Docket Number	NL02 1186 US	

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. ¹	Document Number No.-Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns Lines, Where Relevant Passages or Relevant Figures Appear
DL	1	US- 6,040,728	3/21/2000	Nelson, et al	
		US-			
		US-			
		US-			
		US-			

FOREIGN PATENT DOCUMENTS					
Examiner Initials*	Cite No. ¹	Document Number (ctry ² -no.-kind ³ , if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of cited document	Pages, Columns Lines, Where Relevant Passages or Relevant Figures Appear

NON-PATENT LITERATURE DOCUMENTS				
Examiner Initials*	Cite No. ¹	Include name of the author (in capital letters), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.		
DL	2	LIU T ET AL: "A negative feedback based substrate coupling noise reduction method", ASIC/SOC Conference, 1999. PROCEEDINGS. TWELFTH ANNUAL IEEE INTERNATIONAL, WASHINGTON, DC, USA 15-18 SEPT. 1999, PISCATAWAY, NJ, USA, IEEE, US, 9/15/1999, pages 49-53		
DL	3	CHAN H.H.Y ET AL: "Substrate coupled noise reduction and active noise suppression circuits for mixed-signal system-on-a-chip designs" PROCEEDINGS OF THE 44TH. IEEE 2001 MIDWEST SYMPOSIUM ON CIRCUITS AND SYSTEMS. MWSCAS 2001. DAYTON, OH, AUG. 14-17, 2001, MIDWEST SYMPOSIUM ON CIRCUITS AND SYSTEMS, NEW YORK, NY: IEEE, US, vol. 1 of 2, 8/14/2001, pages 154-157		

Examiner Signature	<i>Thanket</i>	Date Considered	7/17/06
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* EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Unique citation designation number. ² See attached Kinds of U.S. Patent Documents. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

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